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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yoshiharu Kirakata et al. Art Unit : 2811
Serial No. : 10/656,170 Examiner : David Nhu
Filed : September 8, 2003 Confirmation No.: 9943
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JANUARY 26, 2004

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.

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